



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 1957

SERIAL NUMBER 10/539,883	FILING or 371(c) DATE 06/17/2005 RULE	CLASS 349	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. DE1642
APPLICANTS Jaehwan Eun, Jeonju-si Jeonrabuk-do, KOREA, REPUBLIC OF; Sang-Goo Lee, Siheung-si, Kyungki-do, KOREA, REPUBLIC OF; Hyeongjoon Kim, Seongnam-si, Kyungki-do, KOREA, REPUBLIC OF; Minchan Kim, Jeju-si, Jeju-do, KOREA, REPUBLIC OF;				
** CONTINUING DATA ***** This application is a 371 of PCT/KR03/01391 07/14/2003				
** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 1020020080745 12/17/2002 REPUBLIC OF KOREA 1020030012846 02/28/2003				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED *** SMALL ENTITY **				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/BOB M KUNEMUND/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 4	TOTAL CLAIMS 16
INDEPENDENT CLAIMS 1				
ADDRESS ANDERSON, KILL & OLICK, P.C. 1251 AVENUE OF THE AMERICAS NEW YORK, NY 10020-1182 UNITED STATES				
TITLE Method for preparation of ferroelectric single crystal film structure using deposition method				
FILING FEE RECEIVED 630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	